

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	) : Examiner: C. E. Church
Yoshinori OHSAKI	)
	: Group Art Unit: 2882
Application No.: 09/577,608	) : Confirmation No.: 6496
Filed: May 25, 2000	) :
For: POSITIONING APPARATUS, ATMOSPHERE SUBSTITUTING METHOD, EXPOSURE APPARATUS, AND DEVICE MANUFACTURING METHOD	January 20, 2004 ((Tuesday after Federal Holiday)
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	RECEIVED  JAN 22 2004  TECHNOLOGY CENTER 21
<u>AMENDMENT</u>	80

Sir:

In response to the Official Action dated October 17, 2003, the time to respond to which having been extended to Tuesday, January 20, 2004 a day after a Federal Holiday, please amend the above-identified application as follows: